

N THE UNITED STATES PATENT AND TRADEMARK OFFICE

Art Unit: 2815

Examiner: Richards, N. Drew

In re application of:

Gonzalez et al.

SEMICONDUCTOR RAISED SOURCE-DRAIN STRUCTURE

Serial No.: 10/008,653

Filed: November 9, 2001

RESPONSE ACCOMPANYING REQUEST FOR CONTINUED EXAMINATION

May 10, 2005

Mail Stop RCE Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

Sir:

A. Introductory Comments

Applicants respectfully request entry of the following amendments and remarks in response to the final office action mailed February 17, 2005

Claims 17, 125, and 128 have been amended. Claims 17, 98-103, 125-126, and 128 are now pending in the application. No new matter has been added. Applicants respectfully request favorable reconsideration and further examination of this application in view of the following amendments and remarks.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 7 of this paper.